



The Compact Muon Solenoid Experiment
Conference Report

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Study of Interpad-gap of FBK (UFSD3) and HPK 3.1 Type sensors with Transient Current Technique

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Abstract

The Phase-II upgrade of LHC to HL-LHC by 2026 allows an increase in the operational luminosity value by a factor of 5-7 that will result in delivering 3000 fb^{-1} or more integrated luminosity. This amount of data will not just be a factor of 200. To cope with high pileup rates, precision timing detector (MTD) that will measure minimum ionizing particles (MIPs) with 40 ps and hermetic coverage up to a pseudo-rapidity of $|\eta| = 3$ is proposed by the CMS experiment. An endcap part (1.6 t η gain avalanche detector (LGAD) technology. The third production of UltraFast Silicon Detectors (UFSD3) from Fondazione Bruno Zevi (FBK) has been carried out. Results of measured inter-pad gap widths and spatial mappings with active regions using MIPs (IRlight) from the Scanning-Transient Current Technique (Scanning-TCT) set-up will be shown. A fill-factor, which is the ratio of the area within the active region (Gain region) to the area of the detector, varies depending on temperature (from 25 C to -25 C) and proton fluence on irradiation will also be shown.

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Study of Interpad-gap of HPK 3.1 production LGADs with Transient Current Technique^{*}

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Abstract

The Phase-II upgrade of the Large Hadron Collider (LHC) to High-Luminosity LHC (HL-LHC) allows an increase in the operational luminosity value by a factor of 5–7 that will result in delivering 3000 fb^{-1} or more integrated luminosity. To achieve high luminosity, the number of interactions per bunch crossings (pileup) will increase up to a value of 140–200. To cope with high pileup rates, precision minimum ionizing particles (MIPs) timing detector (MTD) with a time resolution of $\sim 30\text{--}40$ ps and hermetic coverage up to a pseudo-rapidity of $|\eta| = 3$ is proposed by the Compact Muon Solenoid (CMS) experiment. An endcap part ($1.6 < |\eta| < 3$) of the MTD, called the endcap timing layer, will be based on low-gain avalanche detector (LGAD) technology. The 3.1 production of LGADs from Hamamatsu Photonics K.K. (HPK) include 2x2 sensors with different structural strategies, in particular, different nominal values of narrower inactive region widths between the pads. These sensors have been designed to study their fill factor, which is the ratio of the area within the active region (gain region) to the total sensor area. A comparative study on the dependence of breakdown voltage with the interpad-gap width for the sensors has been carried out. Using MIPs (infrared light) from the Scanning-Transient Current Technique (Scanning-TCT) set-up show that the fill factor does not vary significantly with a variation in temperature and at high proton fluence irradiation.

Keywords: Low Gain Avalanche Detector (LGAD), Scanning-TCT, Fill Factor

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1. Introduction

The High Luminosity Large Hadron Collider (HL-LHC) era, also known as the Phase-2 operation of the LHC, will be functional after Long Shutdown 3 (LS3). During the HL-LHC phase, the number of interactions per bunch crossings will increase to an average value of 140 corresponding to a nominal luminosity of $5.0 \times 10^{34} \text{ cm}^{-2}\text{s}^{-1}$. Ultimately, the luminosity will be leveled up to a nominal value of $7.5 \times 10^{34} \text{ cm}^{-2}\text{s}^{-1}$, at the cost of producing 200 interactions per each bunch crossing. The amount of collected data corresponding to an integrated luminosity of 3000 fb^{-1} , will increase the precision of the Standard Model (SM) measurements and the sensitivity for Beyond Standard Model (BSM) searches [1]. Due to additional beam collisions, spatial overlapping of the tracks and energy deposition will cause a degradation in the particle identification and reconstruction of the tracks during the hard interaction. In addition, the radiation damage caused due to the high collision rate integrated over time can not be tolerated by the existing detectors. Therefore, the upgraded detector must be able to survive and function efficiently in the radiation harsh environment. It should also be able to mitigate the problem of high pileup rates by transporting a much higher rate of data off the detector to be recorded for analysis.

In the upgrade plan for the HL-LHC era, the Compact Muon Solenoid (CMS) experiment will install a precision minimum ionizing particles timing detector (MTD) to measure minimum ionizing particles (MIPs) with a time resolution of nearly 30-40 ps, degrading slowly to a magnitude of 50-60 ps due to radiation damage. The MTD will allow time of arrival (ToA) measurements that can separate the collisions very close in space as well as in time with a hermetic angular coverage up to a pseudo-rapidity of $|\eta| = 3$ [2].

The MTD will be a thin layer between the tracker and the electromagnetic calorimeter of the CMS experiment. It will consist of a barrel ($|\eta| < 1.5$) and an endcap part ($1.6 < |\eta| < 3$). The endcap part of the MTD, known as the endcap timing layer (ETL), will be based on low gain avalanche detector (LGAD) technology. The timing resolution and performance of the ETL depends upon the optimal design of the sensors which can be achieved when each of the hits as particles cross the two silicon layers have high gain, low noise and uniform response. These objectives can be achieved by studying and optimising some of the crucial features of the LGADs, which are: fill factor, wafer uniformity, quality of multi-pad sensors, single pad leakage current, hit efficiency and signal uniformity, gain and noise, long term stability and time resolution [3].

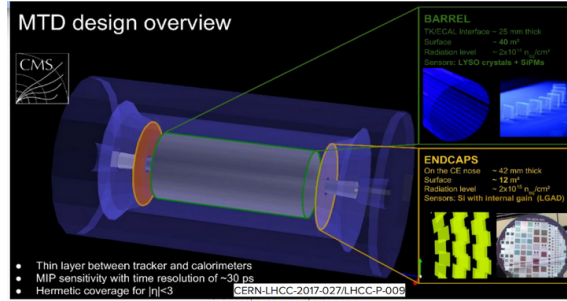


Figure 1: CMS MTD design layout showing the positioning of its barrel and endcap part [4]

36 In this report, the authors have focused on the study of fill factor which is the
 37 ratio of the active area and the total sensor area. This value can be less than 100%
 38 due to the edge width and the no-gain region between the pads. The fill factor
 39 depends upon the nominal distance between adjacent pads of the sensors, known as
 40 the interpad-gap. Further, the breakdown voltage of the sensors depends upon the
 41 design of the gain termination region which is affected with the nominal interpad-gap
 42 value.

43 The 3.1 production batch LGADs provided by one of the competitive vendors,
 44 Hamamatsu (HPK), have been studied in this report. The specification of the sam-
 45 ples have been mentioned in Section 2. I-V characterisation of the sensors (shown in
 46 Section 3.1) with varying interpad-gaps shows how the breakdown voltage depends
 47 upon the inaction region width. Further, since the gain of these sensors depends
 48 upon temperature and proton fluence of irradiation, the interpad-gap and fill fac-
 49 tor have been studied with these varying factors by using the Scanning Transient
 50 Current Technique (TCT) set-up (shown in Section 3.2).

51 2. Samples Measured

52 The samples measured are sensors from HPK 3.1 production batch. The design
 53 of the sensors studied are according to 2019 CMS MTD Technical Proposal (TP) [2].
 54 The thickness of the active p-type bulk region of the sensors is of a magnitude of
 55 50 μm . The sensors have four pads (2×2) with a common guard ring around them.
 56 Each of the pads has an area of $1 \times 3 \text{ mm}^2$. The difference in the samples is the
 57 distance between the adjacent pads, called interpad-gap. The nominal values of
 58 interpad-gap are 30 μm , 50 μm , 70 μm and 95 μm , respectively. The sensors have
 59 been categorised into two types: Type A and Type B on the basis of their structural
 60 prototypes (as shown in Figure 2).

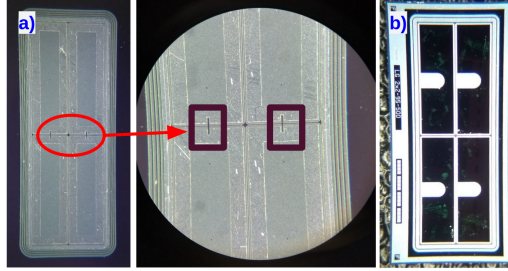


Figure 2: HPK 3.1 production sample with 2×2 sensor showing sensors a) with broader metallisation region on pads and small optical opening running across adjacent pads (Type A) and b) individual pads with wider optical opening (Type B).

61 3. Measurements

62 3.1. IV-CV Measurements

63 Capacitance versus Voltage (C-V) and Current versus Voltage (I-V) measure-
 64 ments were performed at the probe station in the Detector Laboratory in Helsinki
 65 Institute of Physics (HIP), Finland. Capacitance⁻² versus Voltage plot from C-V
 66 measurements shows that the full depletion voltage of the sensors is of a magnitude
 67 of 50 V.

68 I-V measurements of sensors with varying nominal interpad-gaps were performed
 69 in two different modes depending upon the floating/grounding configuration of the
 70 remaining pads while current was readout from one of the pads (shown in Figure 3).
 71 The sensors have a breakdown voltage of 220 V. The breakdown voltage is indepen-
 72 dent of the floating and/or grounding configuration of the remaining pads for sensors
 73 with 50 μm , 70 μm and 95 μm nominal interpad-gap; but is not the same for the
 74 ones with 30 μm nominal interpad-gap (shown in Figure 3a and 3b). This shows
 75 that the breakdown voltage is dependent upon the design of the gain termination
 76 region and the nominal value of interpad-gap.

77 3.2. Scanning-Transient Current Technique Measurements

78 TCT is a method commonly used for electrical characterisation of semiconductor
 79 detectors. The measurements in this study were performed by Particulars (Ljubljana,
 80 Slovenia) based Scanning-TCT setup [5]. Optical excitation was performed with an
 81 infrared (IR) laser ($\lambda = 1064\text{nm}$) directed on the optical opening in front plane of
 82 the sensor. The measurements were performed at low a laser intensity of 62.5 %,
 83 equivalent to 4-5 MIPs, in order to study the effect due to the gain layer. The bias
 84 voltage is applied to the back plane of the sensor while the transient signal is read
 85 from the front. The laser illumination generates charge carriers within the bulk of

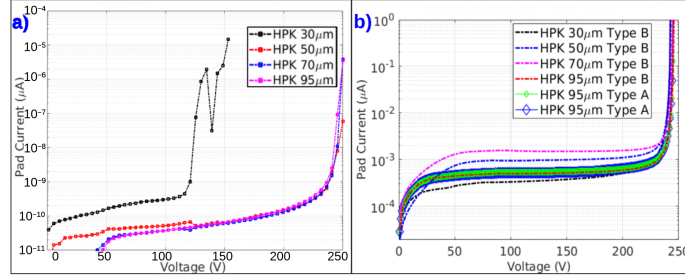


Figure 3: Current versus voltage plots of HPK 3.1 sensors wherein: a) Current is readout from one the pads while the three pads are left floating. Guard ring is grounded. b) Current is readout from one of the pads, while the other pads as well as the guard ring are grounded. Note: All the plots are in logarithmic scale.

86 the active depleted region. Since the sensors have a p-type bulk, under reverse-bias
 87 mode, the transient signal is due to the electrons that are quickly gathered to the
 88 front-end electrode. Therefore, the resulting signal read out by an oscilloscope is a
 89 fast signal of 2.5 ns width.

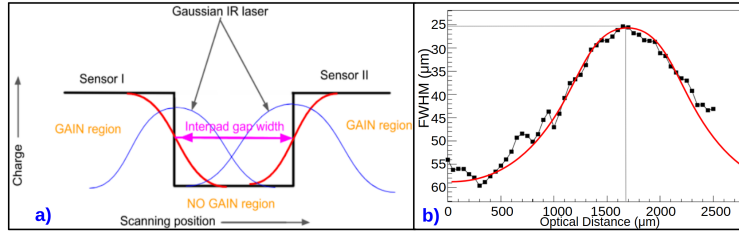


Figure 4: a) Measured interpad-gap is the distance between the mid-point of the S-curves of adjacent sensors. b) FWHM vs Optical distance of the IR laser from sensor. Gaussian shape IR spot with size: 25 μm . Focus position of the laser: 1650 μm .

90 In addition to the IR laser, the other components in measurement setup were a
 91 focusing optics, a sample holder mounted on a XYZ stage for scanning the entire
 92 surface of the detector, a Keithley 2410 1100 V Sourcemeter unit, 180 V (maximum
 93 allowance) Bias-Tee, a wide band current amplifier with a Tenma power supply, a
 94 LeCroy WaveRunner 8404M-MS 4 GHz oscilloscope and a PC and DAQ with LAB-
 95 view based software. The repetition rate of the laser is adjustable from 5 kHz to
 96 500 kHz. During the measurements, more than one hundred waveforms were recorded
 97 while scanning the laser illumination through the optical opening across two adja-
 98 cent pads. The laser pulse was transmitted to the detector by an optical fiber. On
 99 performing a focus scan, the size of the Gaussian laser spot was determined to be of
 100 a magnitude of 25 μm (shown in Figure 4 b). The interpad profile observed in TCT

101 scan is a convolution of step function and the Gaussian beam of IR laser: S-curve
 102 (as shown in Figure 4 a). The curve fitting function is an error-function of the form

$$f(x) = a + \left[\frac{b}{2} \times \operatorname{erf} \left\{ \frac{\sqrt{2}(x - c)}{d} \right\} \right] \quad (1)$$

103 The step ends (= gain layer ends) at 50% of the convoluted function. This
 104 50% value of the convoluted function (S-curve) is determined by parameter c of
 105 equation (1) . We compute the measured interpad-gap width as the distance between
 106 the 50% amplitude points of the two interpad profiles (i.e. the distance between 2
 107 gain layers) of adjacent pads [2].

108 3.2.1. Measured interpad-gap with varying temperature:

109 The study on temperature dependence on the internal gain of LGADs plays an
 110 important role in the sensor performance due to its impact ionisation rate which is
 111 inversely proportional to the mean free path of the carriers [6]. Since the impact
 112 ionisation of the sensors depends on temperature, a proper understanding of the
 113 LGAD functionality with temperature variation is crucial as the gain affects the
 114 time resolution as well as the breakdown voltage of the detector [7].

115 Since the gain increases with a decrease in temperature [7], the charge collected
 116 increases as the temperature decreases. Figure 5a shows the pulse shape and ampli-
 117 tude of the signals recorded by the LeCroy oscilloscope as the laser is projected at
 118 the optical opening of one of the pads. The amplitude of the signal increases by a
 119 factor of 2.5 as the temperature is decreased from 25°C to -25°C. This is coherent to
 120 the increase in the charge collected due to the gain layer as the laser is projected at
 121 the optical opening of the sensor. The normalised value of collected charge increases
 122 by a factor of 2.8 as the temperature decreases from 25°C to -25°C [8].

123 The interpad-gap as well the leakage current were measured with temperature
 124 variation from 25°C to -25°C at a constant bias voltage of 180 V (shown in Figure 5).
 125 As expected, the leakage current value measured at a constant voltage of 180 V
 126 decreases by nearly an order of magnitude [8]. The measured interpad-gap values
 127 and the calculated fill factor of different sensors with varying nominal interpad-gaps
 128 have been tabulated in Table 1. It shows the percentage decrease in the interpad-
 129 gap as well as the variation in fill factor with varying temperature. The measured
 130 interpad-gap for the HPK 3.1 production sensors has an offset of approximately
 131 40 μm from the the nominal value. This is coherent to the values measured at test
 132 beams in FNAL (measured at room temperature), mentioned in the MTD TDR
 133 2019 [2]. The fill factor values measured at room temperature are also consistent
 134 with the measured fill factor provided in the MTD TDR 2019 [2].

HPK Sensor (nominal interpad-gap)	Measured Interpad-gap of sensor				Fill factor			
	At 25°C (in μm)	At 0°C (in μm)	At -25°C (in μm)	Decrease from 25°C to -25°C (in %)	At 25°C (in %)	At 0°C (in %)	At -25°C (in %)	Increase from 25°C to -25°C (in %)
30 μm	71.7	63.1	62.4	12.97	89.71	89.73	89.74	0.03
50 μm	90.3	88.1	85.3	5.54	87.62	87.67	87.71	0.09
70 μm	104.3	101.5	99.1	4.98	85.60	85.68	85.69	0.09
95 μm	128.3	128.2	125.5	2.18	82.50	82.52	82.53	0.03

Table 1: Variation in the measured interpad-gap and fill factor with temperature.

135 We observe that with a decrease in temperature from 25°C to -25°C, the measured
136 interpad-gap decreases by a 2-13 %. However, the change in fill factor value is not
137 significant as it increases by 0.1 %.

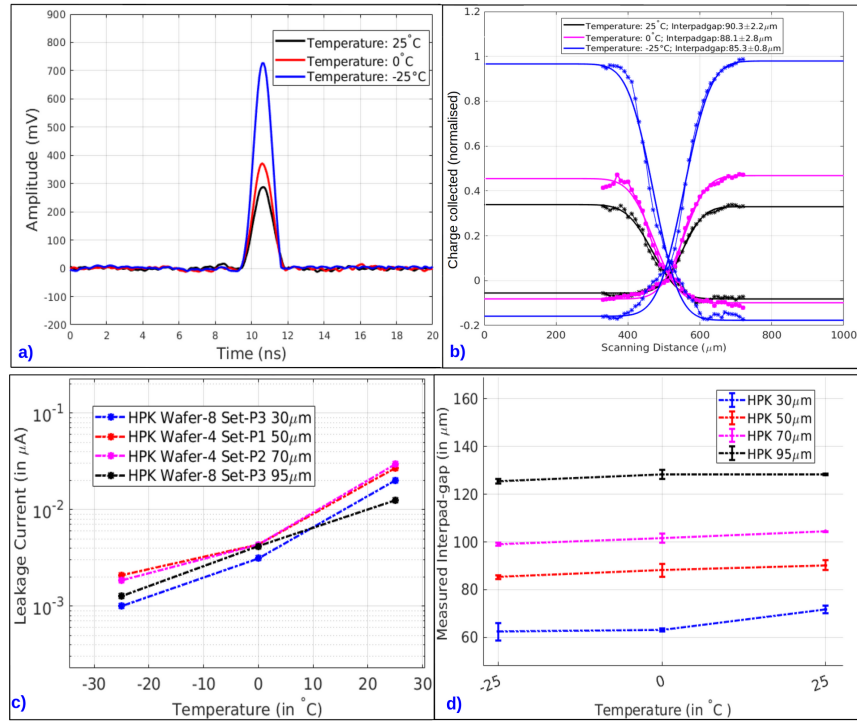


Figure 5: a) Pulse shapes, b) Charge Collected (normalised value) vs scanning distance for sensors (at 25°C, 0°C and -25°C) as the laser scans across two adjacent sensors with 50 μm nominal interpad-gap, c) Leakage current with varying temperature and d) Variation in the measured interpad-gap with temperature. Measurements were performed at a voltage of 180 V.

HPK Sensor (nominal interpad-gap)	Measured interpad-gap of sensor							
	Un-irradiated (in μm)	Irradiated at 5×10^{14} p/cm ² (in μm)	% decrease	Decrease in Fill factor (in %)	Un-irradiated (in μm)	Irradiated at 5×10^{14} p/cm ² (in μm)	% decrease	Decrease in Fill factor (in %)
30 μm	68.1	41.4	39.21	0.11	66.0	57.6	1.73	0.11
50 μm	84.8	68.2	19.58	0.39	83.2	70.7	15.02	0.25
70 μm	103.0	84.5	17.96	1.41	101.1	89.8	11.18	0.93
95 μm	117.8	97	17.66	0.80	125.0	-	-	-

Table 2: Variation in the measured interpad-gap and fill factor with proton fluence.

138 *3.2.2. Measured Interpad-gap with varying proton fluence:*

139 The HPK 3.1 production sensors with different nominal interpad-gap values were
 140 irradiated with 10 MeV protons at the IBA cyclone 10/5 cyclotron in Department
 141 of Chemistry in University of Helsinki [9]. The sensors were placed in a sample
 142 holder consisting of collimation slits (of dimensions approximately close to the area
 143 of the sensors) such that the integrated current read out from the Keithley 6487 Pi-
 144 coammeter is due to the irradiation of the sensors. The beam profiling was done
 145 in such a way that the sample placed under slit 1 and 3 (shown in Figure 5) gets
 146 an integrated current of $0.15 \mu\text{A}/\text{cm}^2$ while sensors under slit 2 and 4 (shown in
 147 Figure 5) of the sample holder receive an integrated current of $0.09 \mu\text{A}/\text{cm}^2$. Four
 148 samples were irradiated simultaneously over 1040 s such that samples in 1 and 3 are
 149 irradiated with a fluence of 10^{15} protons/cm² while 2 and 4 are irradiated with a
 150 fluence of 5×10^{14} protons/cm². Total integrated current read out from the four slits
 151 was $0.42 \mu\text{A}\cdot\text{hr}$. Note: sensor with 95 μm nominal interpad-gap irradiated at 10^{15}
 152 protons/cm² underwent breakdown even at low bias voltages.

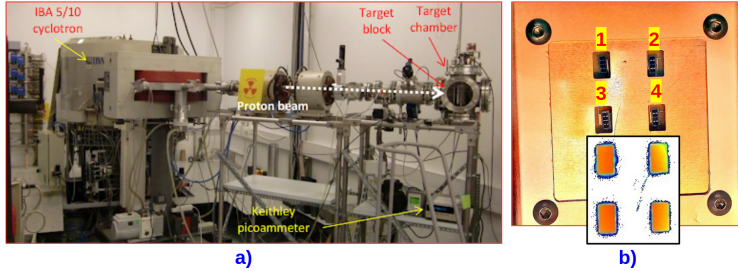


Figure 6: a) IBA 10/5 cyclotron in the Department of Chemistry, b) Collimator with sample holder showing autoradiograph (using Ag foil) of the beam profile across the four collimation slits.

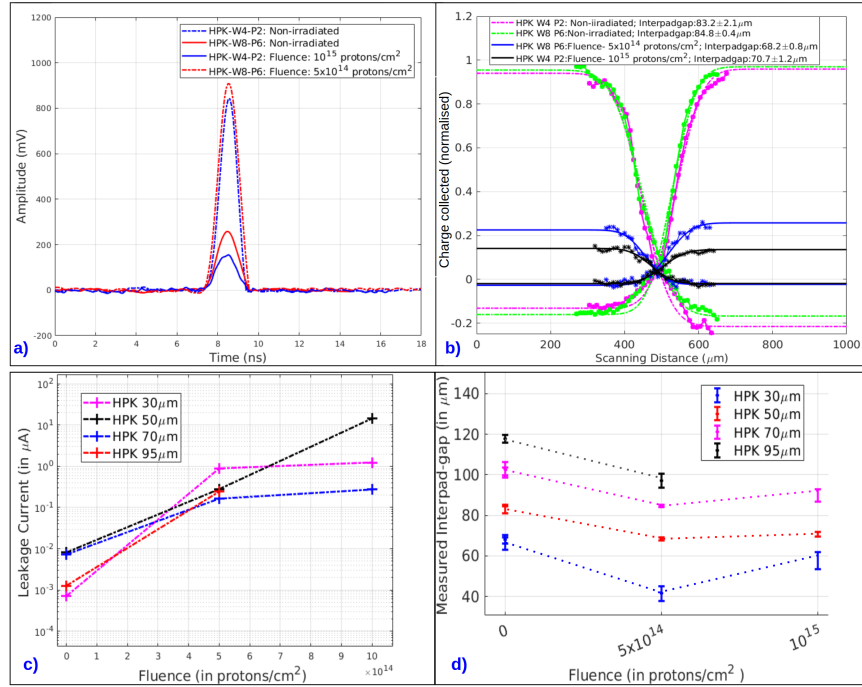


Figure 7: a) Pulse shape of non-irradiated and irradiated samples at different proton fluences and b) Charge Collected (normalised values) vs. scanning distance for sensors as the laser scans across two adjacent pads for sensors with 50 μm interpad-gap. c) Leakage current with varying fluences and d) Variation in the measured interpad-gap with proton fluence for sensors with 30 μm , 50 μm , 70 μm and 95 μm interpad-gap measured at 180 V and temp: -25°C .

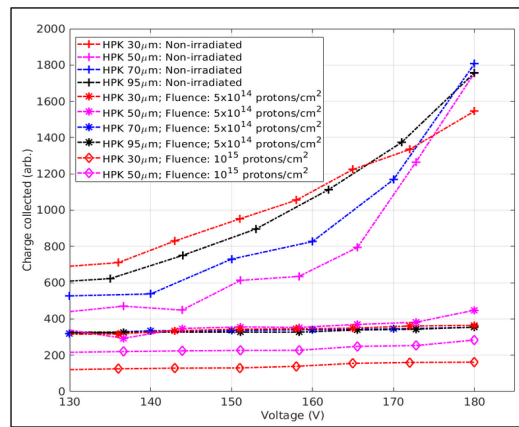


Figure 8: Voltage scans for the non-irradiated and irradiated samples with varying inter-pad gaps measured at -25°C .

153 The performance of LGADs is affected due to the removal of the acceptor atoms
154 in the gain layer of the device [10]. As a result of which it worsens the time resolution
155 [11] as well as an increase in the leakage current due to the bulk which is unrelated
156 to the gain mechanism [12]. This can be observed in Figure 7c where the leakage
157 current value measured at 180 V at a constant temperature of -25°C , increases by
158 three orders of magnitude with an increase in proton fluence. Further, trapping of
159 charge carriers leads to lower signals (shown in Figure 7a) and hence the degradation
160 of the spatial resolution and the efficiency (as shown in Figure 8) [13, 14].

161 At a fluence of 5×10^{14} protons/cm², interpad-gap is reduced by 20-40% from
162 its value before irradiation and the collected charge decreases by a factor of 3-4
163 due to trapping of charge carriers causing a degradation in the charge collection
164 efficiency [13]. However, on irradiating the sensors at 10^{15} protons/cm², interpad-
165 gap increases in comparison to its value at 5×10^{14} protons/cm², since its charge
166 collection efficiency decreases by factor of 6. Therefore, on irradiating the sensors
167 at 10^{15} protons/cm², the value of the measured interpad-gap decreases by 11-15%
168 from its value before irradiation. Correspondingly, even though the interpad-gap
169 decreases with an increase in fluence, the fill factor decreases by approximately 1%
170 as the spatial homogeneity is worsened due to the effect of irradiation.

171 4. Conclusions and summary

172 The fill factor values for HPK 3.1 production LGADs with different nominal
173 interpad-gap were measured by varying temperature and irradiating them at different
174 proton fluences. The signal waveform as well as the CCE of the detectors were studied
175 by recording 1064 nm wavelength IR-laser induced current transients with a TCT
176 measurements set-up . The measurements were performed at 180 V and low laser
177 intensity. During the measurement campaign four hundred waveforms were recorded
178 at each micron step as the laser scans across adjacent pads of the sensor in order to
179 obtain the measured interpad-gap profile.

180 Since gain is dependent on temperature, the CCE increases with a decrease in
181 temperature. Our results show that the measured interpad-gap decreases by 2-12 %
182 as the temperature decreases from 25°C to -25°C . However, the fill factor is not
183 affected significantly by changing temperature as its value increases by approximately
184 0.1%.

185 Further, the measured interpad-gap decreases on irradiating the sensors at vary-
186 ing proton fluences, Due to acceptor removal of the gain layer, the CCE decreases
187 by a factor of 4–6 with irradiation at high proton fluences. At 10^{15} protons/cm²,
188 our studies show the measured interpad-gap decreases by 11-15%. However, at the

189 fill factor decreases by 0.1-0.9%. This change is not significantly large. Thus, we
190 conclude that the fill factor does not change significantly with temperature and ir-
191 radiation at varying proton fluences.

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